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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)		Application Number	10/607,542
		Filing Date	June 27, 2003
		First Named Inventor	Akihisa SHIMOMURA et al.
		Group Art Unit	2812
		Examiner Name	Stanetta Isaac
		Attorney Docket Number	0756-7171
Sheet	1		

U.S. PATENT DOCUMENTS						
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		Number	Kind Code <sup>2</sup> (if known)			
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Examiner Signature	Stanetta Isaac	Date Considered	4/02/06
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